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Attorney Docket No. 0756-2447

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/084,935

Filed: March 1, 2002

For: INSULATING FILM AND METHOD
OF PRODUCING SEMICONDUCTOR
DEVICE

) Group Art Unit: 2815

) Examiner: Jerome Jackson, Jr.

) CERTIFICATE OF MAILING

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) 2006.

Adulm Stampen

RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed August 14, 2006, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Accordingly, the Applicant respectfully submits that this response is being timely filed.

Initially, it is noted that the Applicant would like to discuss the present application with the Examiner. The Applicant will contact the Examiner to arrange a mutually agreeable time and place for the interview.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on March 1, 2002; June 4, 2002; October 3, 2002; April 11, 2003; December 16, 2003; and March 27, 2006.

Claims 19-26 and 35-62 are pending in the present application, of which claims 19, 35, 43 and 51 are independent. For the reasons set forth in detail below, all claims are believed to be in condition for allowance. Favorable reconsideration is requested.

The Official Action rejects claims 19-26 and 35-62 under 35 U.S.C. § 112, first paragraph, asserting that "there is no support for an 'interlayer insulating film' having the